

Attorney's Docket No. 05-022-con/Tank-190con

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Joseph H. Johnson et al.

U.S. Serial No:

Group Art Unit:

Date Filed: September 4, 2003

Examiner:

Title: "HIGH PERFORMANCE ACTIVE AND PASSIVE  
STRUCTURES BASED ON SILICON MATERIAL BONDED TO  
SILICON CARBIDE."


Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Enclosed is a copy of Information Disclosure Citation Form PTO-1449 together with copies of the documents cited on that form. It is respectfully requested that the cited documents be considered and that the enclosed copy of Information Disclosure Statement Form PTO-1449 be initiated by the Examiner to indicate such consideration and a copy thereof returned to applicant(s).

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450  
on: (date of Deposit) September 4, 2003  
(Typed or printed name of person mailing correspondence) Boris G. Tankhilevich  
(Signature of person mailing correspondence) 

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Pursuant to 37 C. F. R. Section 1.97, the submission of this Information Disclosure Statement is not construed as a representation that a search has been made and is not to be construed as an admission that the information cited in this statement is material to patentability.

Pursuant to 37 C. F. R. Section 1.97, this Information Disclosure Statement is being submitted under one of the following (as indicated by an "X" to the left of the appropriate paragraph):

  X   37 C. F. R. Section 1.97(b)

       37 C. F. R. Section 1.97(c) If so, then enclosed with this Information Disclosure Statement is one of the following:


- A certificate pursuant to 37 C. F. R. Section 1.97(e) or
- A check for \$        for the fee under 37 C. F. R. Section 1.17(p).

       37 C. F. R. Section 1.97(d). If so, then enclosed with this Information Disclosure Statement are the following:

- (1) A certificate pursuant to 37 C. F. R. Section 1.97(e);
- (2) A petition requesting consideration of this Information Disclosure Statement; and
- (3) A check for \$        for the fee under 37 C. F. R. Section 1.17(i) for submission of the Information Disclosure Statement.

Dated: September 4, 2003

Respectfully submitted,

  
Patent Attorney  
Boris Tankhilevich  
Reg. No. 38,689

Sheet 1 of 1

Form PTO-1449				Docket Number (Optional) <u>05-022-001/Tank 190241</u>		Application Number	
<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> (Use several sheets if necessary)				Applicant <u>JOSEPH H. JOHNSON et al.</u>		Group Art Unit	
				Filing Date <u>SEPT. 4, 2003</u>			

U. S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	<u>5488232</u>	<u>01-30-1996</u>	<u>Glass et al.</u>				
	<u>6117751</u>	<u>09-12-2000</u>	<u>Schoerner et al.</u>				
	<u>6426968</u>	<u>07-30-2002</u>	<u>Strife et al.</u>				

FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
	<u>Hiroaki Nagasawa, Kuniaki Yagi, Takamitsu Kawahara and Naoki Hatta; "3C-SiC Monocrystals Grown on Undulant Si(001) Substrate" Pg. 47450; Material Research Society Vol. 742 © 2002</u>
	<u>Zhiyun Cheng et al.; "Relaxed Silicon-Germanium On Insulator (SGOI); Material Research Society Symp. Proc. Vol. 666; 2002 Pg. 21-26</u>

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.